

Appl	ication/Control No.	Applicant(s)/Patent under Reexamination	
10/0	45,073	RUELLAN ET AL.	
Exan	niner	Art Unit	
CHA	MELI C. DAS	2192	

SEARCHED							
Class	Subclass	Date	Examiner				
717	107,108	9/10/05	es				
717	168-173						
718	106						
709	166 201	4	4				
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INTERFERENCE SEARCHED						
Subclass	Date	Examiner				
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
WF ST	9/10/05	W		
-uspathib				
-usock				
- us py pub				
-JPO Abs				
-EPO Abs				
- DWPI				
- IBM Tech				
Aem				
IBBE	↓			
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